DEC 1 5 2003 10110-3:MRS:as:254534

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of:	)	I hereby certify that this correspondence is being deposited with the United States Postal Service as first
Hiromichi Ohta, et al.	) Before the Examiner )	class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313 on December 10, 2003
Serial No. 09/615,883	) Jennifer C. McNeil	Date of Deposit  Matthew R. Schantz
Filed July 14, 2000	) ) Group Art Unit 1775	Name of Registered Representative
LOW-RESISTANCE ITO THIN FILM AND METHOD FOR MANUFACTURING SUCH	) December 10, 2003 )	December 10, 2003  Date of Signature
A FILM	· )	

## AMENDMENT AFTER NON-FINAL ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

Sir:

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TO 1700

Inventor(s): Ohta and Orita

Examiner: J. C. McNeil

Filed: July 14, 2000 Group Art Unit: 2812

In response to the non-final Office Action entered in the above application and dated June 10, 2003 ("Office Action" herein), please consider the following. Applicants request that the date for responding to the Office Action be extended three months to and including December 10, 2003, and enclose the fee of \$950.00 for this request is enclosed. Additionally, please charge any additional fees that may be due to Account No. 23-3030, but not to include any payment of issue fees.

An Amendment to the Claims is reflected in the listing of claims that begins on page two of this paper.

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